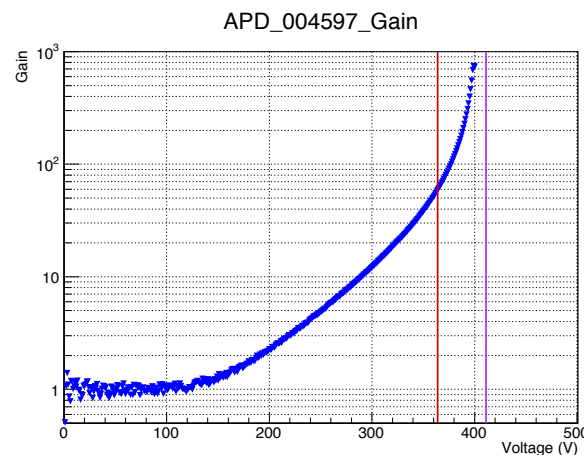
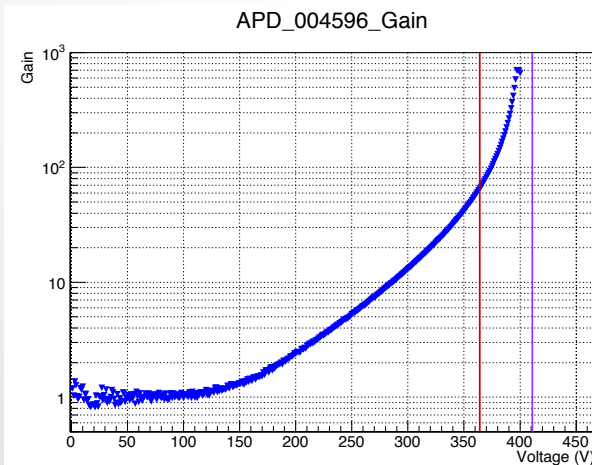


LAAPD with CREMAT CSP

M. Bizzarri, C. Cecchi, P. Lubrano, E.
Manoni, A. Papi, A. Rossi, G. Scolieri

LAAPD Gain

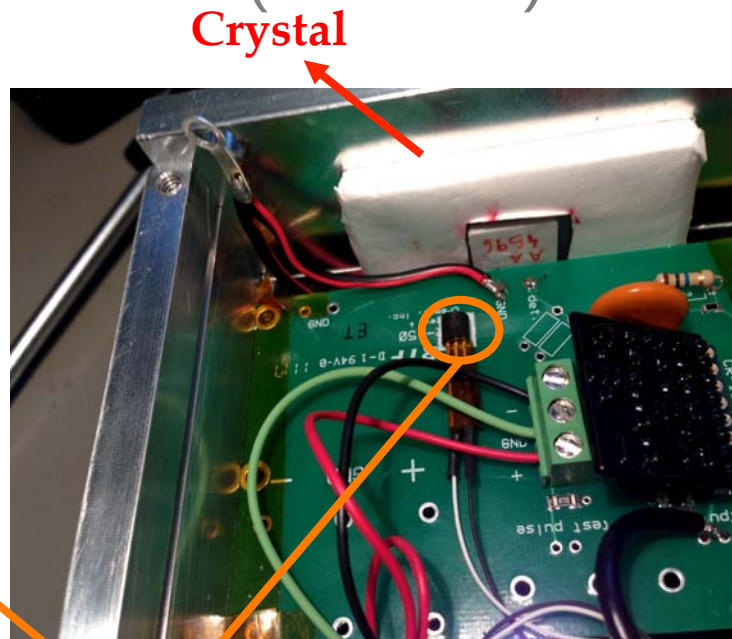
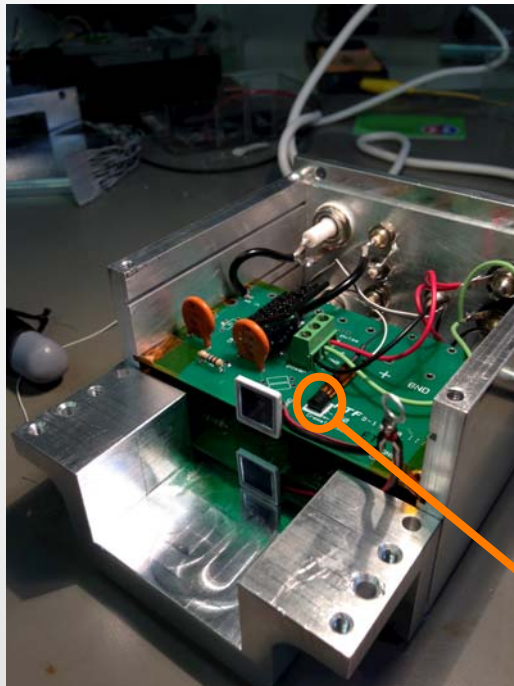
- Hamamatsu data for APDs
 - $G=50$ $HV=364V$
 - $V_{bd}=411V$
 - Based on this info we measured a $G=190$ @ $400V$
- Gain measurement performed with LED
 - Differences with hamamatsu data!
- Gain values based on new measurement
 - $G=200 \rightarrow HV1=385.8V$ $HV2=388.5V$
 - $V_{bd}=400V$ for both APDs



— Hamam. $G=50$
— Hamam. V_{bd}

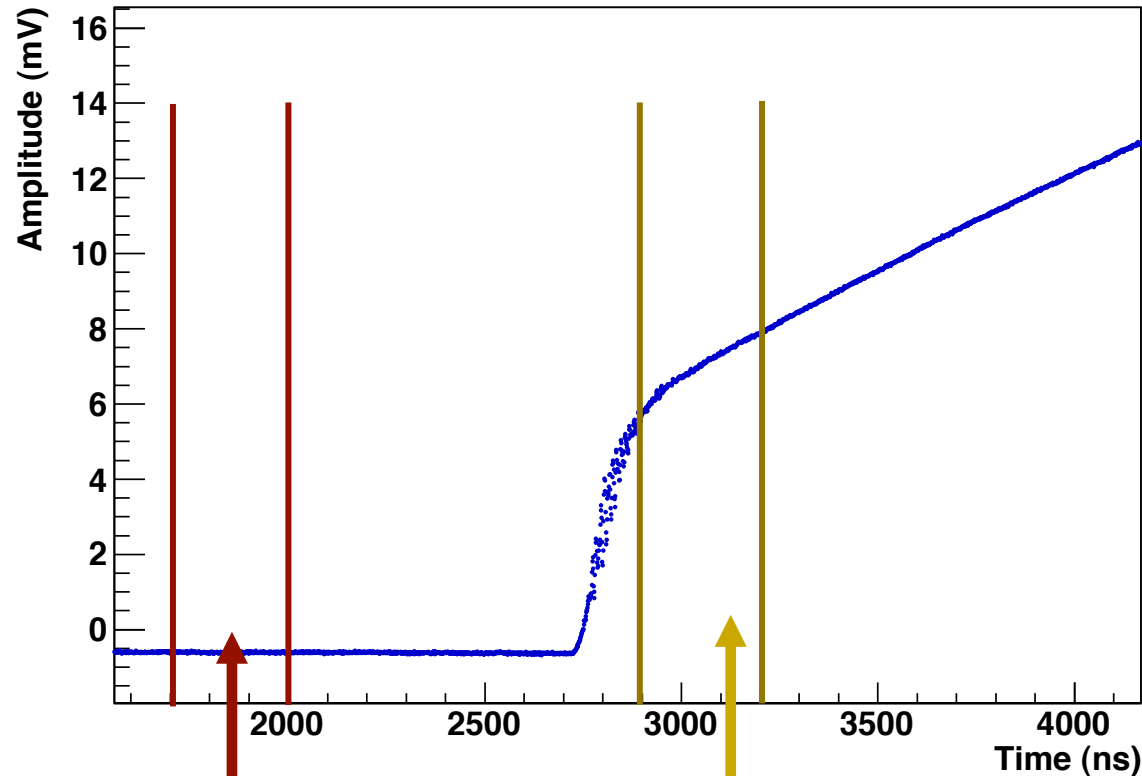
SetUp

- Two LAAPD Hamamtsu
- Two CR-150 board with CR-110 CSP
- APD soldered directly on PCB board
- Temperature sensor (DS18S20) inside shield



CSP Signal Extraction

Mean waveform Ch1

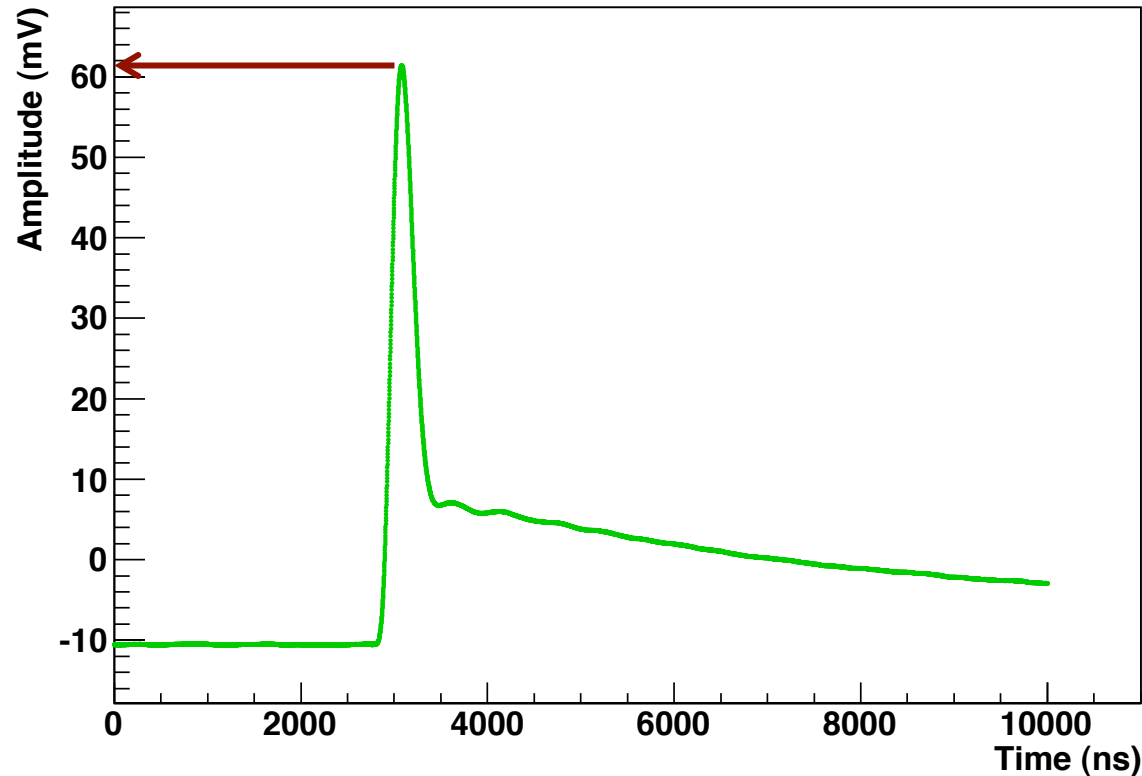


Pedestal: Mean value Signal: Mean value

- Pedestal: mean value in a windows 300ns wide
- Signal: mean value in a windows 300ns wide

Shaper Signal Extraction

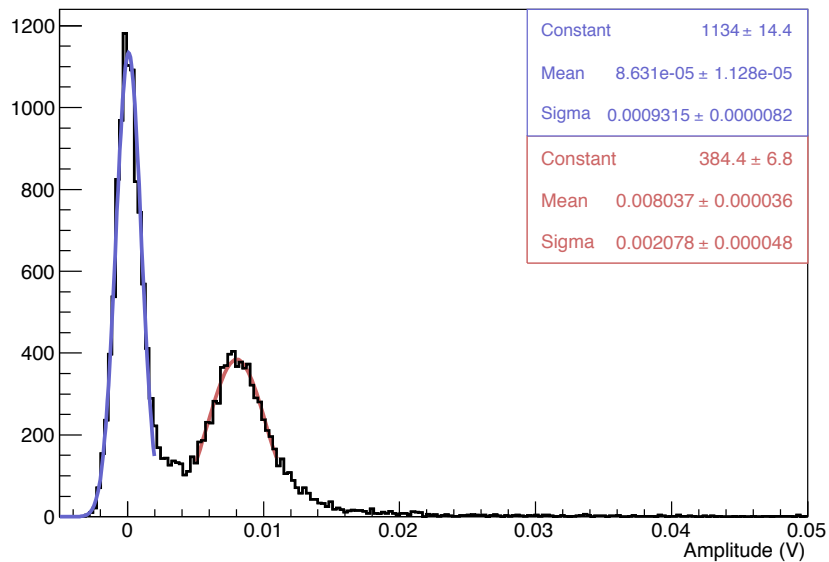
Mean waveform Ch3



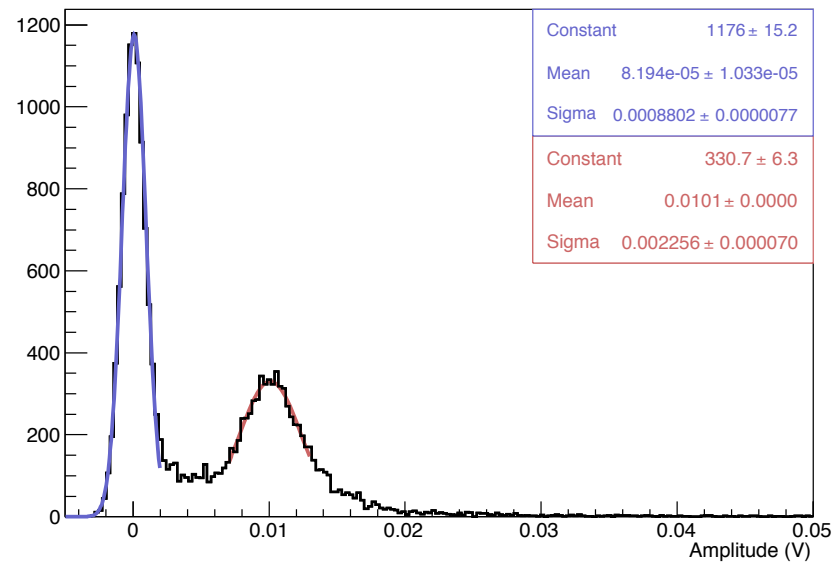
- Signal: Maximum value (all time window allowed)
- No pedestal subtraction performed

Single LAAPD (50Ω)

CSP CREMAT - LAAPD1 - Mean Method



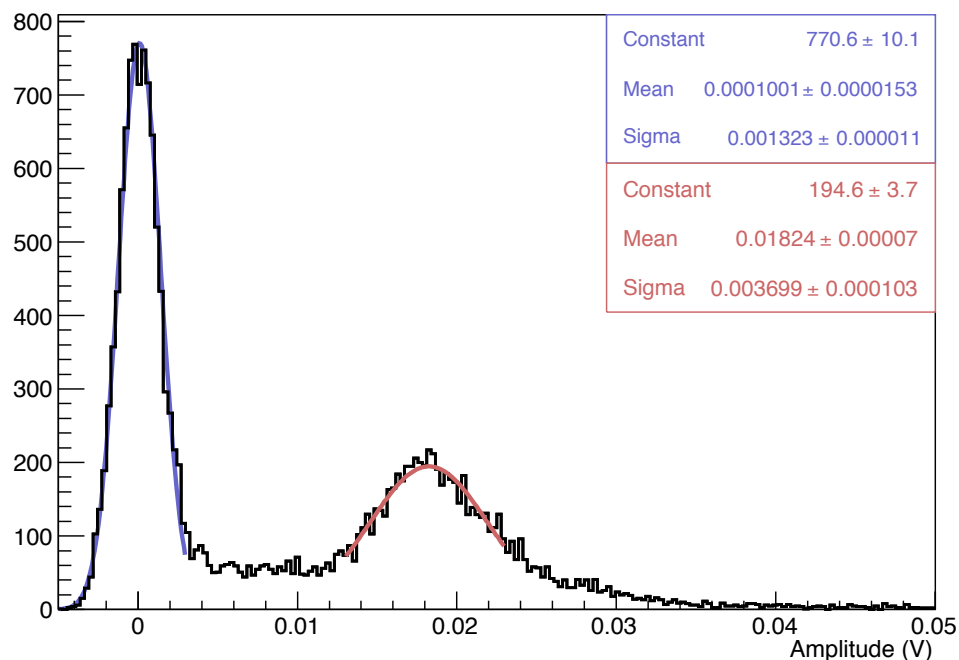
CSP CREMAT - LAAPD2 - Mean Method



	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	8.04 ± 0.04	0.931 ± 0.008	8.63 ± 0.09	3.48 ± 0.03
LAAPD2	10.10 ± 0.01	0.880 ± 0.008	11.47 ± 0.11	2.61 ± 0.03

LAAPD SUM (50 Ω)

CSP CREMAT - LAAPD Sum - Mean Method



This run was
acquired without
monitoring
temperature

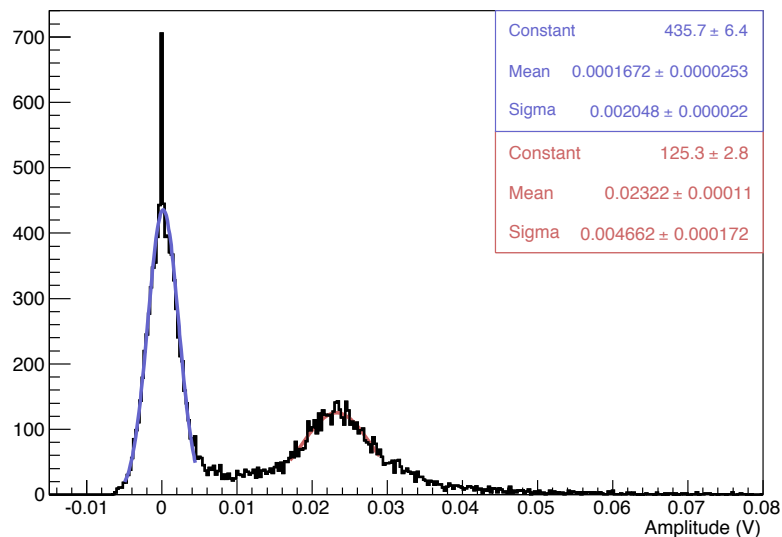
	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	8.04 ± 0.04	0.931 ± 0.008	8.63 ± 0.09	3.48 ± 0.03
LAAPD2	10.10 ± 0.01	0.880 ± 0.008	11.47 ± 0.11	2.61 ± 0.03
LAAPD Sum	18.24 ± 0.07	1.323 ± 0.011	13.78 ± 0.13	2.18 ± 0.01

Shaper HW

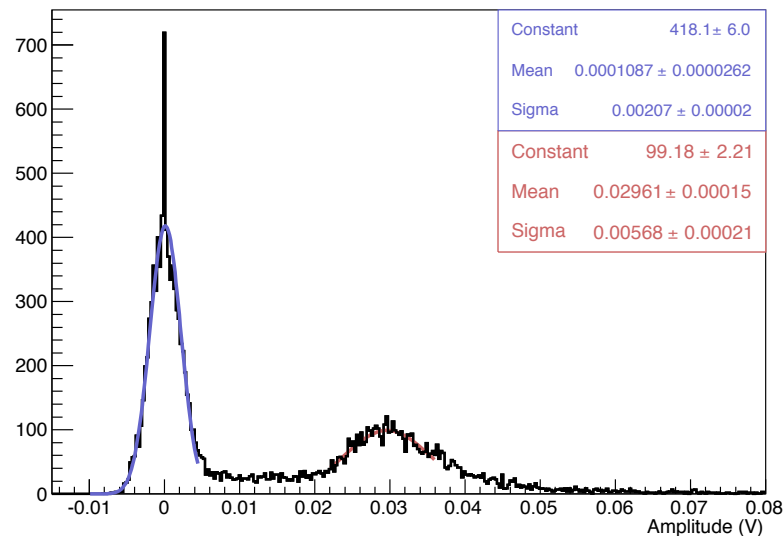
- CREMAT shapers have an input impedance of $1\text{K}\Omega$
 - When we use this devices the CSP signal is terminated with $1\text{K}\Omega$ and not with 50Ω
 - Absolute value of signal and noise higher
 - S/N constant

CSP Single LAAPD (1K Ω) – Run SHP100

CSP CREMAT - LAAPD1 - Mean Method



CSP CREMAT - LAAPD2 - Mean Method

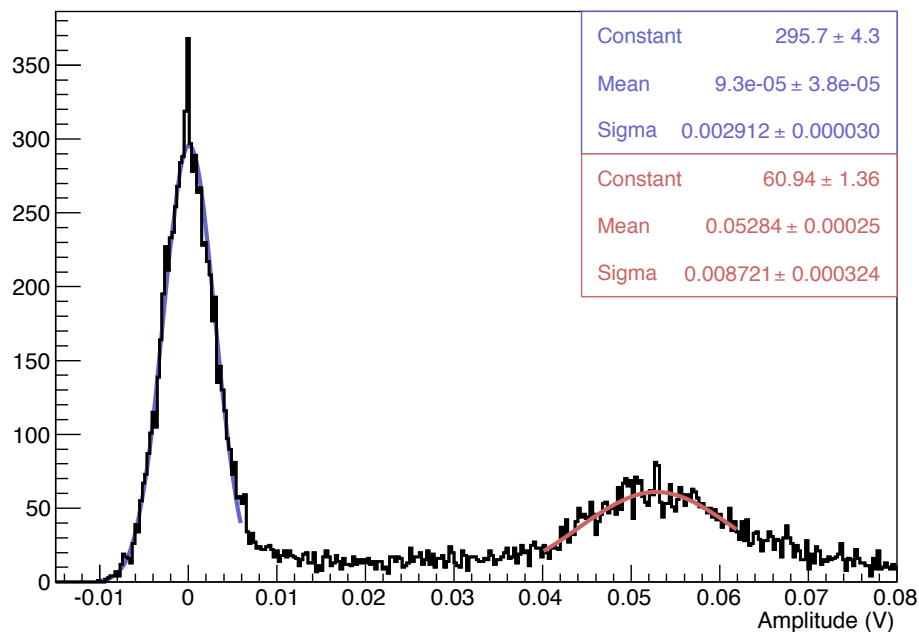


	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	23.2 $\pm$ 0.1	2.05 $\pm$ 0.02	11.3 $\pm$ 0.2	2.65 $\pm$ 0.03
LAAPD2	29.6 $\pm$ 0.2	2.07 $\pm$ 0.02	14.3 $\pm$ 0.2	2.10 $\pm$ 0.02

- Run temperature $T=19.8\pm0.2^{\circ}\text{C}$

CSP LAAPD SUM (1K Ω) – Run SHP100

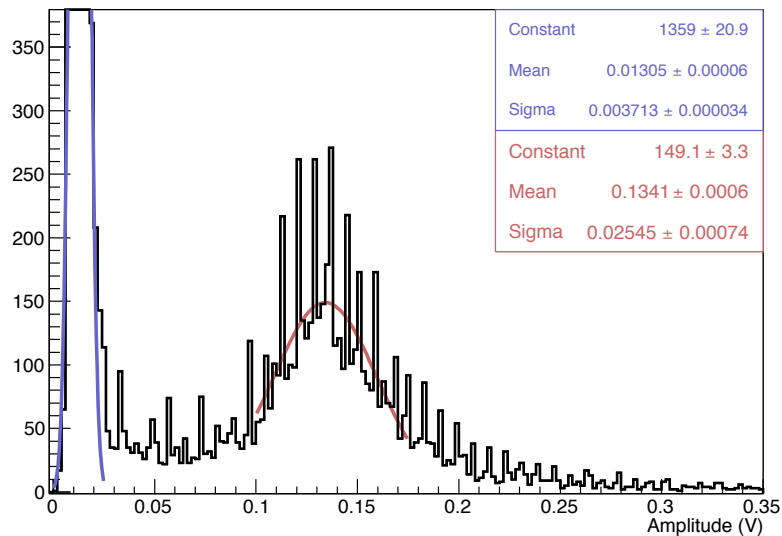
CSP CREMAT - LAAPD Sum - Mean Method



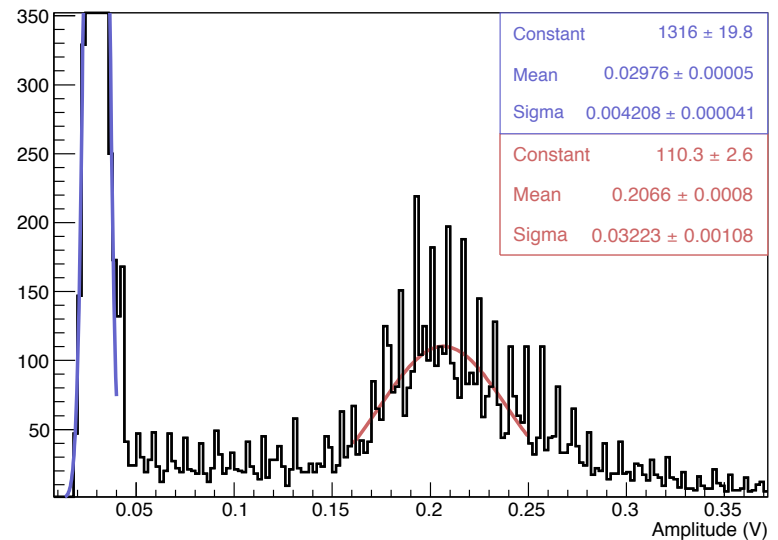
	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	23.2 $\pm$ 0.1	2.05 $\pm$ 0.02	11.3 $\pm$ 0.2	2.65 $\pm$ 0.03
LAAPD2	29.6 $\pm$ 0.2	2.07 $\pm$ 0.02	14.3 $\pm$ 0.2	2.10 $\pm$ 0.02
LAAPD Sum	52.8 $\pm$ 0.3	2.91 $\pm$ 0.03	18.2 $\pm$ 0.2	1.65 $\pm$ 0.02

Shaping 100ns

CSP CREMAT - LAAPD1 - Shaper 100ns



CSP CREMAT - LAAPD2 - Shaper 100ns

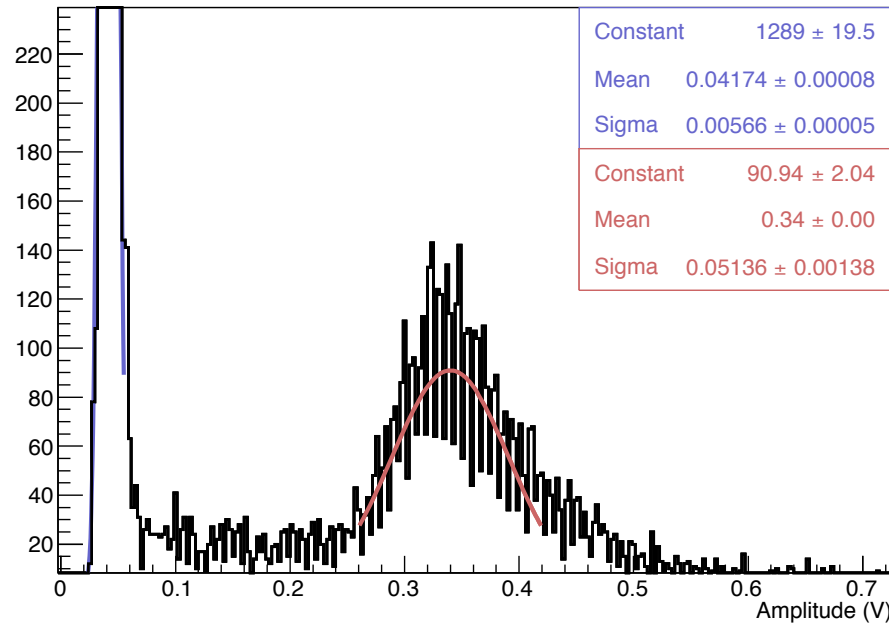


	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	121.1±0.6	3.71±0.03	32.6±0.3	0.91±0.02
LAAPD2	176.8±0.8	4.21±0.04	42.0±0.5	0.71±0.02

→ Oscilloscope ADC has a problem with one bit (probably)

Shaping 100ns - Sum

CSP CREMAT - LAAPD Sum - Shaper 100ns

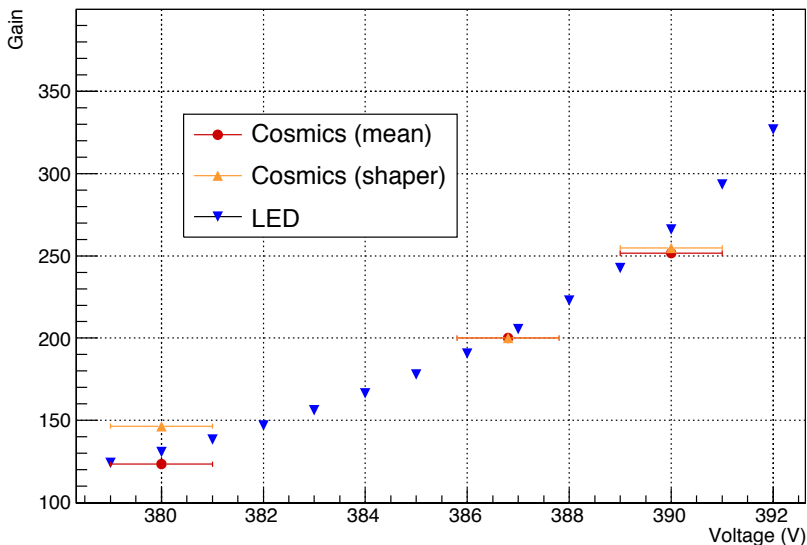


	Signal (mV)	Noise (mV)	S/N	ENE (MeV)
LAAPD1	121.1±0.6	3.71±0.03	32.6±0.3	0.91±0.02
LAAPD2	176.8±0.8	4.21±0.04	42.0±0.5	0.71±0.02
LAAPD Sum	398.3±1.1	5.66±0.05	52.7±0.6	0.55±0.02

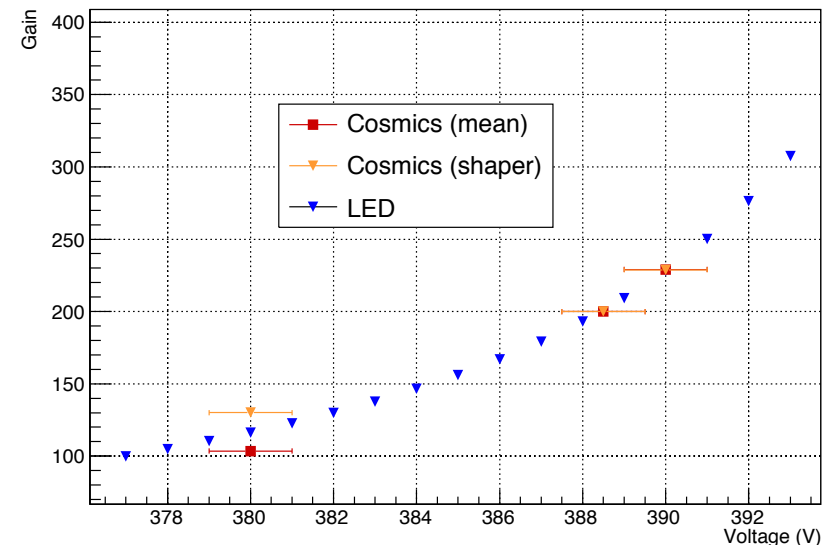
Gain vs HV test

- We assume that $G=200$ point measured with LED is correct
- Cosmics measurement also at 380V and 390V
- Check distribution peak ratio

APD_004596_Gain



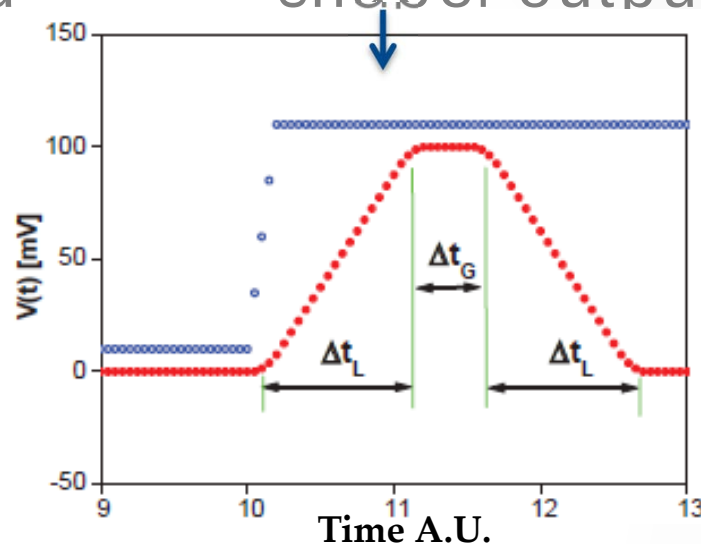
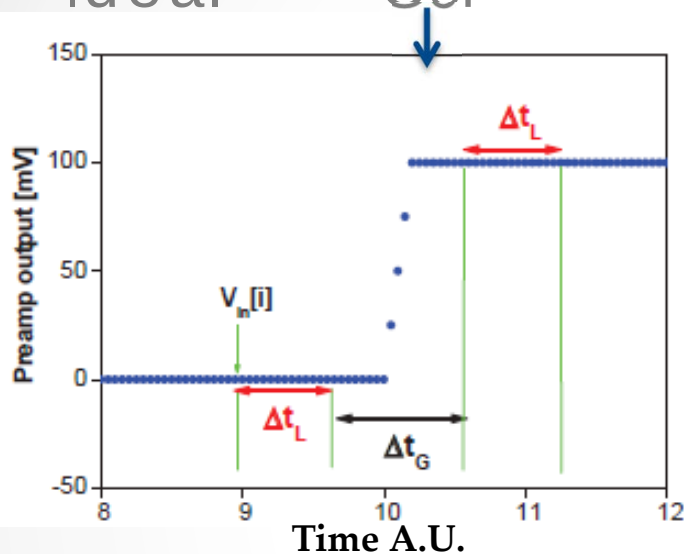
APD_004597_Gain



Software shaping

Algorithm details: trapezoidal filter

- Ideal CSP and Shaper output



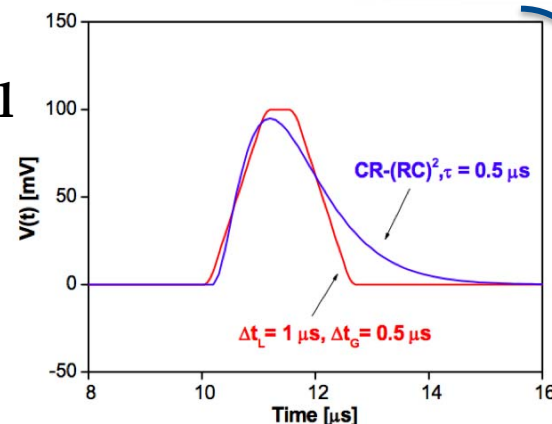
$$V_{av1}[i] = \frac{1}{L} \sum_{j=0}^{L-1} V_{in}[i+j]$$

$$V_{av2}[i] = \frac{1}{L} \sum_{j=0}^{L-1} V_{in}[L+G+i+j]$$

$$V_{out}[i] = V_{av2}[i] - V_{av1}[i]$$

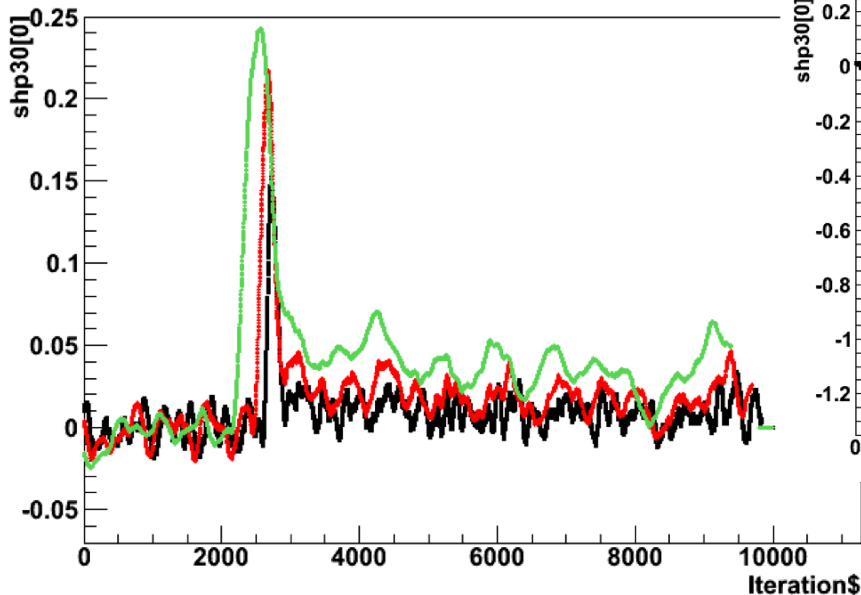
L (G) = number of samples in ΔT_L (ΔT_G)

trapezoidal
filter
vs CR-RC²

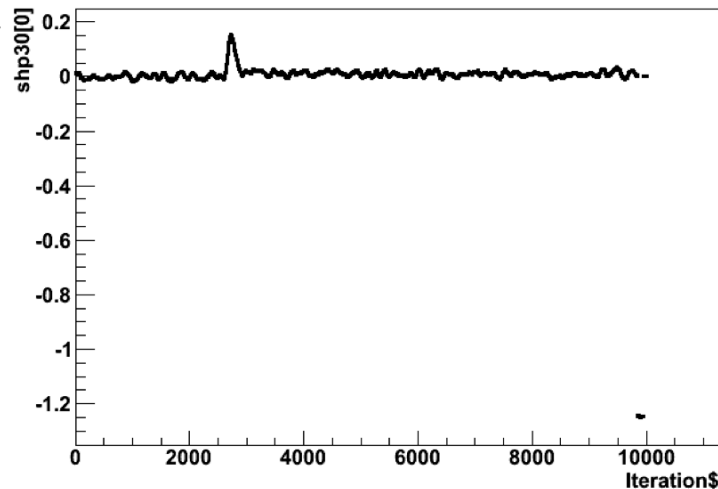


Shaper output and tests on time intervals

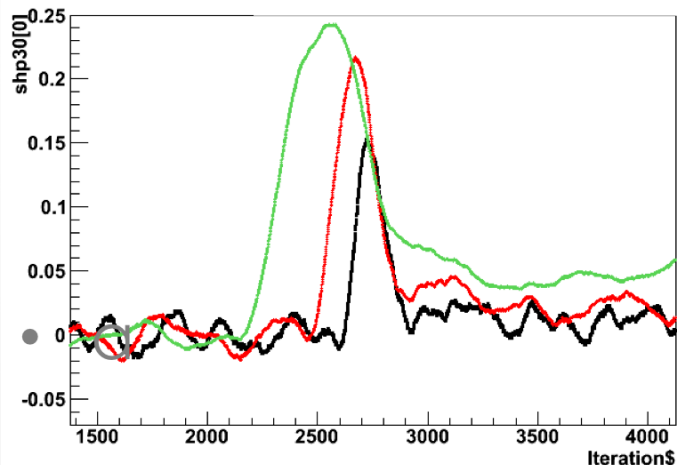
shp30[0]:Iteration\$ {shevent==6}



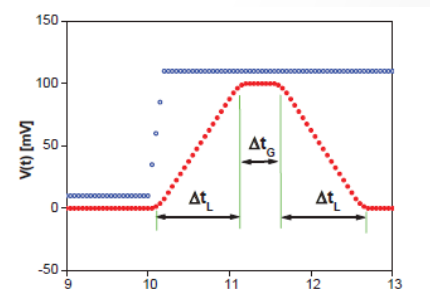
shp30[0]:Iteration\$ {shevent==6}



shp30[0]:Iteration\$ {s}

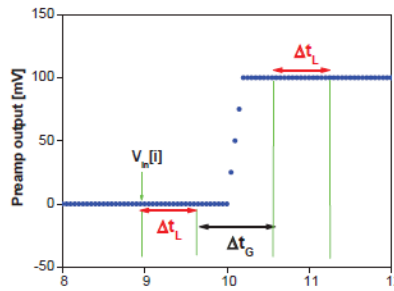


ΔT_L (ns)	ΔT_G (ns)
50	50
100	100
200	200

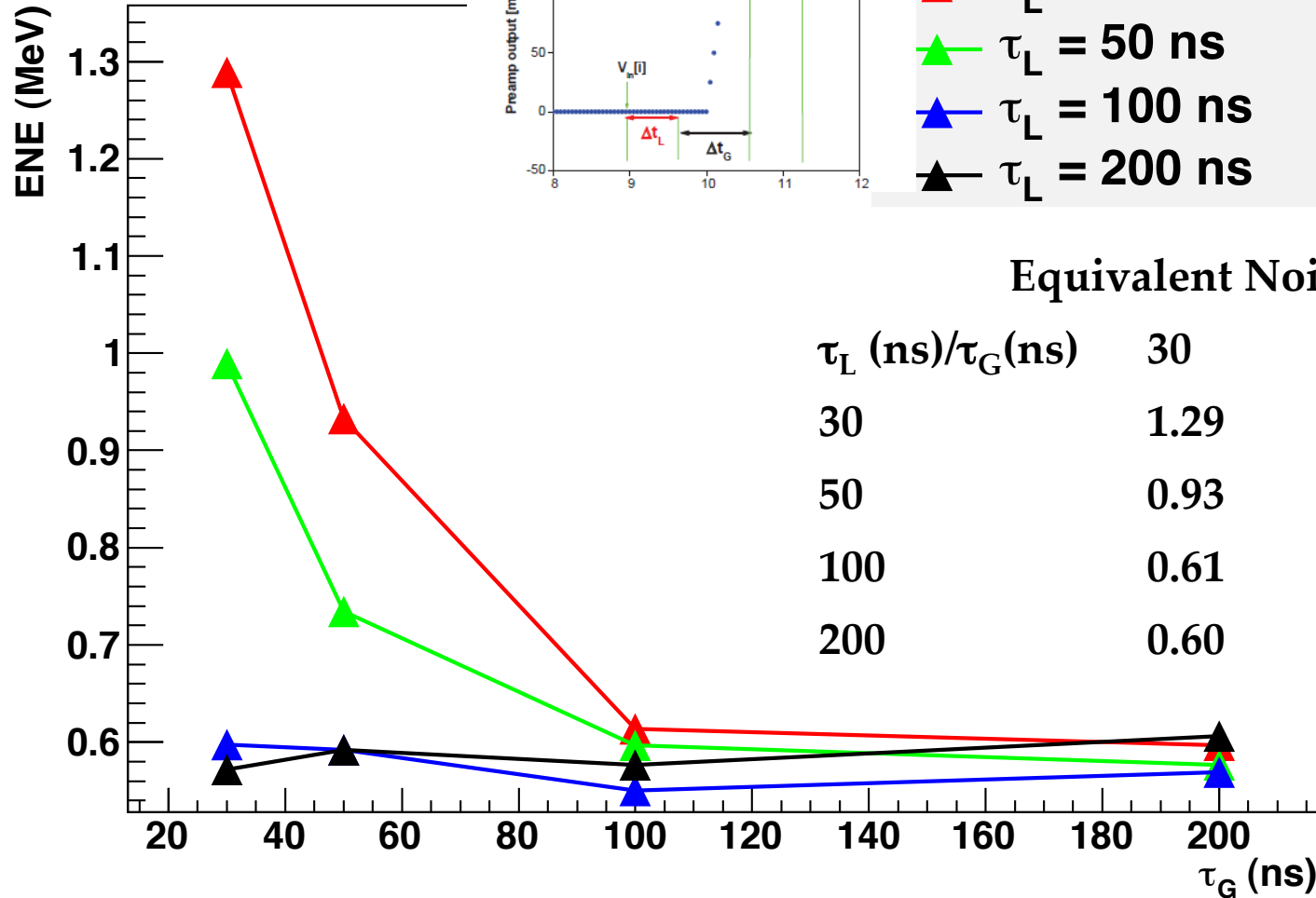


Equivalent noise

$\tau_G - \tau_L$ scan



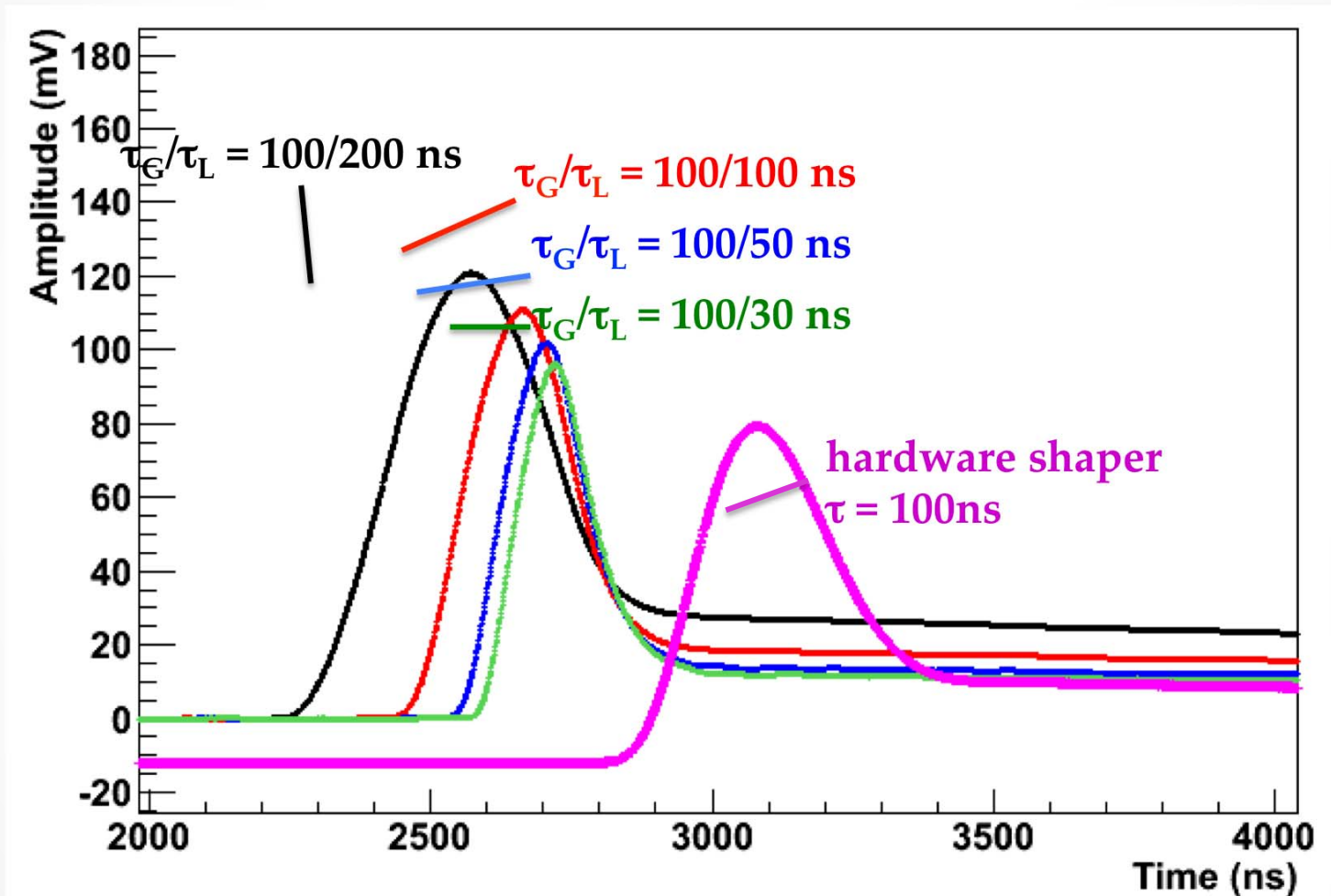
- ▲ $\tau_L = 30$ ns
- ▲ $\tau_L = 50$ ns
- ▲ $\tau_L = 100$ ns
- ▲ $\tau_L = 200$ ns



Equivalent Noise (MeV)

τ_L (ns)/ τ_G (ns)	30	50	100	200
30	1.29	0.99	0.60	0.57
50	0.93	0.73	0.59	0.59
100	0.61	0.60	0.55	0.58
200	0.60	0.58	0.57	0.61

Comparison with hardware shaper



Conclusion (I)

- Checked the APDs gain
 - Some differences with Hamamatsu data
- New working point for both APDs and new mechanical setup
- CSP output with this new configuration down to 1.65MeV ($\sim 20^{\circ}\text{C}$)
- With a 50ns HW shaper we obtain a $\text{ENE}=0.96\text{MeV}$
- With a 100ns HW shaper we obtain a $\text{ENE}=0.55\text{MeV}$ ($\sim 20^{\circ}\text{C}$)
- Gain tested and now we are confident to be in the right working point

Conclusion (II)

- Some tests with trapezoidal software shaping based on the code from Paolo
- In some configuration ($\tau_L=100\text{ns}$ $\tau_G=100\text{ns}$) some results as hardware shaping
 - Noise introduced by hardware shaping is negligible
- More studies on the comparison between this shaping method and CR-RCⁿ are on going

To Do list

- Temperature scan
 - Will be performed in a climatic room in the next days
- Test 4 (small) Hamamatsu APD
 - S8664-55 : active area $5 \times 5 \text{ mm}^2$
- Check APD gain with different wavelength LED
 - At same bias different wavelength have a different response
 - Behavior unknown below 370nm

